



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q76993

Sadayuki OHNISHI

Appln. No.: 10/646,709

Group Art Unit: 2814

Confirmation No.: 9821

Examiner: Phat X. CAO

Filed: August 25, 2003

For: SEMICONDUCTOR DEVICE WITH INTERLAYER DIELECTRIC FILM AND  
MANUFACTURING METHOD THEREOF (AS AMENDED)

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of three month(s), extending the time for responding to the Office Action of December 1, 2005 to June 1, 2005.

A check for the statutory fee of \$1020.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

06/01/2005 SZEWDIE1 00000037 10646709  
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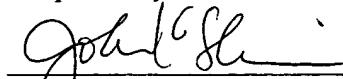
WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: May 31, 2005

Respectfully submitted,

  
John K. Shin  
Registration No. 48,409